



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 8, 2024

IGI Report Number

DESCRIPTION

Shape and Cutting Style

Measurements

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

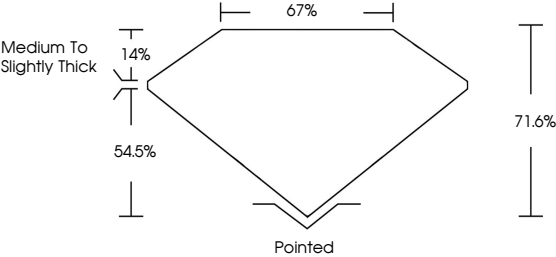
Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

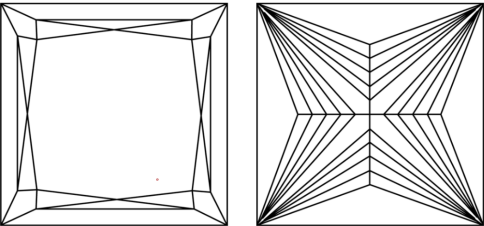
LG658480086

Report verification at [igi.org](#)

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

CLARITY



IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



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LG658480086

LABORATORY GROWN DIAMOND

PRINCESS CUT

5.68 X 5.52 X 3.95 MM

1.13 CARAT

E

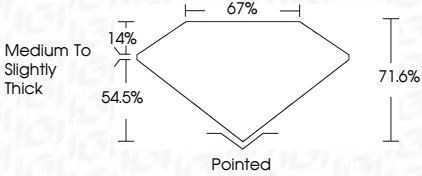
VVS 2

EXCELLENT

EXCELLENT

NONE

IGI LG658480086



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Type IIa

EXCELLENT

EXCELLENT

NONE

IGI LG658480086

October 8, 2024

IGI Report No LG658480086

PRINCESS CUT

5.68 X 5.52 X 3.95 MM

Color Grade

Clarity Grade

Table

Girdle

Medium to Slightly Thick

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG658480086

1.13 CARAT

E

VVS 2

71.6%

67%

Carat Weight

Color Grade

Clarity Grade

Table

Girdle

Culet

Polish

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